



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Eric Frayssinet

Application No.: 10/695,724

Filed: October 28, 2003

For: PROCESS FOR PRODUCING AN

EPITAXIAL LAYER OF GALLIUM

NITRIDE

Art Group: 2823

Examiner: Hsien Ming Lee

<u>PETITION FOR EXTENSION OF TIME AND</u> AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 29, 2005, Applicant submits the following remarks and amendments to the application:

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